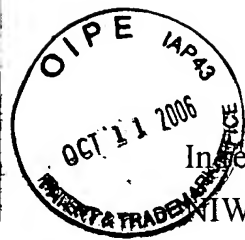


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
NIWA, M.

Atty. Ref.: 2635-184

Serial No. 10/681,138

TC/A.U.: 2856

Filed: October 9, 2003

Examiner:

For: GAS CONCENTRATION DETECTING APPARATUS

\* \* \* \* \*

October 11, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INFORMATION DISCLOSURE STATEMENT**

Attention is directed to the attached JPO Examination Report in a counterpart of this application and to a copy of each non-US patent document newly cited therein. A Form PTO/SB/08a is also attached.

Official consideration and citation of all identified documents is requested.

Respectfully submitted,

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10/681,138

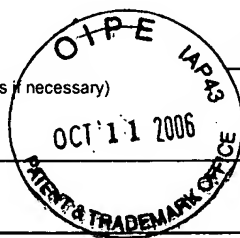
NIWA, M.

TC/A.U.

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(Use several sheets if necessary)

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Date Considered

Form PTO-FB-A820 (Also PTO/SB/08A)